## RECEIVED CENTRAL FAX CENTER

FEB 2 4 2006

S/N 10/825033

PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

**FUJIMORI** 

Examiner:

HSML, P.C.

Nguyen

Serial No.:

10/825033

Group Art Unit:

2812

Filed:

April 14, 2004

Docket No.:

12844.0015USD1

Title:

METHOD OF MANUFACTURING FERROELECTRIC SUBSTANCE

THIN FILM AND FERROELECTRIC MEMORY USING THE

FERROELECTRIC SUBSTANCE THIN FILM

CERTIFICATE UNDER 37 CFR 1.6(d):

I hereby certify that this paper is being transmitted by facsimile to the U.S. Patent and Trademark Office on February 24.

2006.

Do not enter

1th

3-13-6

Mail Stop AF

Commissioner for Patents

P.Q. Box 1450

Alexandria, VA 22313-1450

## <u>AMENDMENT UNDER 37 C.F.R. §1.116</u>

Dear Sir:

In response to the final Office Action mailed November 25, 2005 for the above-identified patent application, Applicant respectfully requests entry and consideration of the following amendment and remarks.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 4 of this paper.